

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

~~MICRON TECHNOLOGY, INC.,
INTEL CORPORATION, AND
GLOBALFOUNDRIES U.S., INC.,~~

~~Petitioners~~

~~v.~~

~~DANIEL L. FLAMM,~~

~~Patent Owner~~

~~Case IPR No. Unassigned
U.S. Patent No. 6,017,221
Issued: January 25, 2000
Named Inventor: _____~~

~~SAMSUNG ELECTRONICS COMPANY, LTD.
Petitioner~~

~~v.~~

DANIEL L. FLAMM
Patent Owner

Patent No. 6,017,221

~~Daniel L. Flamm~~

~~Title: PROCESS DEPENDING ON PLASMA DISCHARGES SUSTAINED BY
INDUCTIVE COUPLING~~

**PETITION FOR *INTER PARTES* REVIEW
OF U.S. PATENT NO. 6,017,221
~~UNDER 35 U.S.C. §§ 311-319 AND 37 C.F.R. §§ 42.1-.80, 42.100-.123~~**

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~~c) [1.2] in which a phase portion and an anti phase portion of capacitive currents coupled from the inductive coupling structure are selectively balanced31~~

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